U.S. DEPARTMENT OF COMMERCE				ATTY DOCKET NO.		SERIAL NO.		
n PTO 1449 dified)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			202450US0		09/770,289		
		(01	PE	APPLICANT				
LIST OF (REFER	ENCES CITED BY APP	LICANT	Atsushi SHIOTA, et al.				
[13] 01 .		1	. V	FILING DATE	GROUP			
		001 0 9 2003		January 29, 2001	1712			
		17.	اربیم این مه	J.S. PATENT DOCUMENTS				
		DOCUMENT	*****		CLASS	SUB		ING DATE
(AMINER I	1	DOCUMENT NUMBER	DATE	NAME	- /- /	CLASS	IF AP	PROPRIATE
MF	AA	6,207,555 B1	03/27/2001	Matthew ROSS	+	/		
ME	AB	6,548,899 B2	04/15/2003	Matthew ROSS	+-/-	 		/_
MF	AC	6,271,146 B1	08/07/2001	Matthew ROSS		 		/
MF	AD	6,582,777 B1	06/24/2003	Matthew ROSS, et al.				
MF	AE	US 2003/0008481 A1	01/09/2003	Matthew ROSS, et al.		\ <i>-</i>		/
ME	AF	6,489,225 B1	12/03/2002	Matthew ROSS, et al.	+	├/	l — /	L
MF	AG	US 2003/0102084 A1	06/05/2003	William LIVESAY, et al.	+	 	-	
MF	AH	6,426,127 B1	07/30/2002	Matthew ROSS, et al.		/	-/-	
ME	AI	6,358,670 B1	03/19/2002	Selmer WONG, et al		1	/	
MF	AJ	6,319,655 B1	11/20/2001	Selmer WONG, et al.		4	/	
1-17	AK					· ·	ļ	
	AL					-		
	AM						 	
	+					1	<u> </u>	
	AN		F	OREIGN PATENT DOCUMENTS		1	1	
	+		F				TRANS	SLATION
	+	DOCUMENT NUMBER	DATE	COUNTRY		Y	TRANS	SLATION NO
MC	+		1		only)	YI		
W£	AN	NUMBER	DATE	COUNTRY	only)	YI		
W£	AN	NUMBER	DATE	COUNTRY	only)	Y		
W£	AO AP	NUMBER	DATE	COUNTRY	only)	Y		
M£	AO AP AQ	NUMBER	DATE	COUNTRY	anly)	YI		
W£	AO AP AQ AR	NUMBER	DATE	COUNTRY	only)	Y		
M\$	AO AP AQ AR AS	NUMBER	DATE	COUNTRY	only)	Y		
W£	AO AP AQ AR AS AT	NUMBER JP2001015500	DATE 01/19/2001	JAPAN (English-language Abstract of				
M£	AO AP AQ AR AS AT AU	NUMBER JP2001015500	DATE 01/19/2001	COUNTRY JAPAN (English-language Abstract of the country of the co	nent Pages	i, etc.)	ES	NO
M\$	AO AP AQ AR AS AT AU	NUMBER JP2001015500 OTHER	DATE 01/19/2001	COUNTRY JAPAN (English-language Abstract of the country of the co	nent Pages	i, etc.)	ES ed Metall	NO NO
	AO AP AQ AR AS AT AU	OTHER J.J. YANG, et al., "E	DATE 01/19/2001 REFERENCE lectron Beam is for ULSI Ap	COUNTRY JAPAN (English-language Abstract of the country of the co	nent Pages Back Proces Society Cor	i, etc.) s". Advanc elerence Pr	ed Metalloceeding	NO No No Ization & Solution &
M£	AO AP AQ AR AS AT AU AV	OTHER J.J. YANG, et al., "E Interconnect System Havemann et al., Marchand	DATE 01/19/2001 REFERENCE: lectron Beam is for ULSI Apiay 1997, pp. 5	COUNTRY JAPAN (English-language Abstract of the country of the co	nent Pages Back Proces Society Con	s, etc.) s". Advance Providerence Provideren	ed Metalloceeding	NO Ization & sp. ed. Robert
MF	AO AP AQ AR AS AT AU AV	OTHER J J YANG, et al., "E Interconnect System Havemann, et al., M J J YANG, et al., "I Advanced Metalliza	DATE 01/19/2001 REFERENCE: lectron Beam is for ULSI Apiay 1997, pp. 5 tion and Interception and Intercepti	COUNTRY JAPAN (English-language Abstract of Japan (English-language Abstract of Japan Stract of Japan Stract of Japan Stract of Stract	nent Pages Back Proces Society Con a Curing for in 1997: Mat	s" Advance Programmer	ed Metall oceeding level Inte	NO Ilization & s. ed. Robert reconnects", ciety Conference
	AO AP AQ AR AS AT AU AV	OTHER J J YANG, et al., "E Interconnect System Havemann, et al., M J J YANG, et al., "I Advanced Metalliza	DATE 01/19/2001 REFERENCE: lectron Beam is for ULSI Apiay 1997, pp. 5 tion and Interception and Intercepti	COUNTRY JAPAN (English-language Abstract of Japan (English-language Abstract of Japan Stract of Japan Stract of Japan Stract of Stract	nent Pages Back Proces Society Con a Curing for in 1997: Mat	s" Advance Programmer	ed Metall oceeding level Inte	NO Ilization & s. ed. Robert reconnects", ciety Conference
MF	AO AP AQ AR AS AT AU AV	OTHER J.J. YANG, et al., "E Interconnect System Havemann, et al., M J.J. YANG, et al., "II Advanced Metalliza Proceedings, ed. R Applied Materials" a	DATE 01/19/2001 REFERENCE: lectron Beam is for ULSI Apiay 1997, pp. 5 tion and Interception and Intercepti	COUNTRY JAPAN (English-language Abstract of Japan (English-language Abstract of Japan Stract of Japan Stract of Japan Stract of Stract of Japan Stract of Jap	nent Pages Back Proces Society Con a Curing for in 1997: Mat	s" Advance Programmer	ed Metall oceeding level Inte	NO Ilization & s. ed. Robert reconnects", ciety Conference

10/3/02